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PATENT APPLICATION

**FILING UNDER 37 CFR §1.312
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 2822**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

ATTN: OFFICE OF PUBLICATIONS

Isao YAMADA et al.

Notice of Allowance Mailed 10/25/05 -
Batch/Confirmation No. 7467

Application No.: 10/502,537

Group Art Unit: 2822

Filed: October 7, 2004

Examiner: Seth W. BARNES

Docket No.: 120524

For: PRODUCTION METHOD OF SIC MONITOR WAFER

AMENDMENT AFTER ALLOWANCE UNDER 37 C.F.R. §1.312

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the October 25, 2005 Notice of Allowability, please consider the following:

Amendments to the Drawings include an attached replacement sheet; and

Remarks.